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PATENT

In The United States Patent and Trademark Office

In re Application of:

Assignee: Technologies and Devices International,
Inc.

Inventors: Vladimir A. Dmitriev, *et al.*

Application No: 10/623,375

Filed: July 18, 2003

Title: Manufacturing Methods for Semiconductor
Devices With Multiple III-V Material Layers

Docket No.: 700625-4001

Art Unit: 1765

Examiner: Song, Matthew J.

CERTIFICATE OF MAILING
UNDER 37 CFR § 1.8

Date of Deposit: March 29, 2005

I hereby certify that this paper and all enclosures are being
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Stop Amendment, Commissioner for Patents, P.O. Box 1450,
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Type or Print Name of Person Mailing: Karen Wuerfel


Signature of Person Mailing

RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, Virginia 22313-1450

Commissioner:

In response to the Office Action mailed December 29, 2004, the Applicants
respectfully submit the following remarks.